## **SIEMENS**

In re Application of:

PATENT Attorney Docket No. 2002P08684WOUS

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Title	METHOD FOR THE DEPO	, SITI	ON OF AN ALLOY	ON A SUBSTRATE
Filed:	June 17, 2005	)	Confirmation No.:	6840
Serial No.:	10/539,938	)	Examiner:	W. T. Leader
Inventor:	Reiner Anton et al.	)	Group Art Unit:	1795

## **Commissioner For Patents**

P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## Response Under 37 CFR 1.111

In response to the Office Action mailed March 30, 2009, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

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